

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Inventor Patent Application of:

Hisashi NAKAMURA et al.

Examiner: M. H. Liu

Application No.: 10/073,959

Art Unit: 2675

Filed: February 14, 2002

Confirmation No.: 8711

For: LIQUID CRYSTAL PROJECTOR COOLING SYSTEM DEPENDENT ON AIR
PRESSURE AND TEMPERATURE VARIABLES (As Amended)

AMENDMENT UNDER 37 C.F.R. §1.111

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MAIL STOP NON-FEE AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

FEB 04 2004

Technology Center 2600

Sir:

I. INTRODUCTORY COMMENTS

In response to the Office Action dated October 28, 2003, please amend the above-identified application as set forth below.

Claims 2 and 3 are pending in the application. By this Amendment, claim 1 is canceled without prejudice or disclaimer and claims 2 and 3 are amended.

II. AMENDMENTS TO THE DRAWINGS

(There are no amendments to the drawings)